

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2829.
#7/dwop
6/4/02
Hayes

Applicant(s): Yoo, Woo Sik
Assignee: WaferMasters, Inc.
Title: Method for Ultra-Thin Film Formation
Serial No.: 09/775,835 Filing Date: January 31, 2001
Examiner: Lisa Kilday Group Art Unit: 2829
Docket No.: M-8250 US

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Newport Beach, California
May 20, 2002

MAY 30 2002

Attn: Official Draftsperson
COMMISSIONER FOR PATENTS Technology Center 2100
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SUBMISSION OF FORMAL DRAWINGS

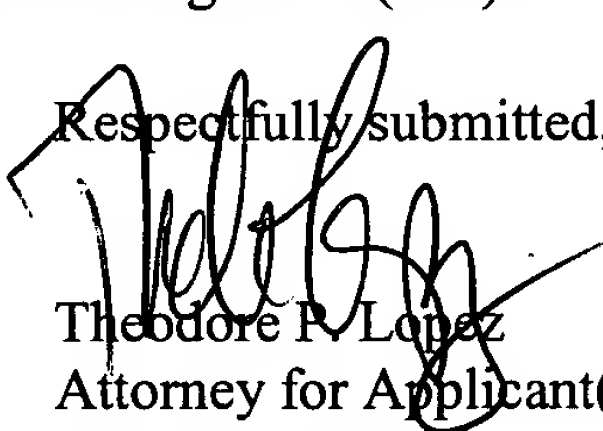
Dear Sir:

Applicant submits five (5) sheets of formal drawings, consisting of Figures 1, 2, 3A, 3B, 4A, 4B, 5B, 6, 7A, 7B, 7C, and 8, in the above-named application. If there are any questions regarding these drawings, please call the undersigned at (949) 718-5200.

EXPRESS MAIL LABEL NO:

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Respectfully submitted,


Theodore P. Lopez
Attorney for Applicant(s)
Reg. No. 44,881

LAW OFFICES OF
SKJERVEN MORRILL LLP

25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979

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